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PATENT

Attorney Reference Number 4641-59018
Application Number 09/942,519

#7A
Amolt
SDavis
8/15/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Okino

Art Unit: 2853

Application No. 09/942,519

Filed: August 29, 2001

For: CHARGED-PARTICLE-BEAM
MICROLITHOGRAPHY METHODS AND
APPARATUS PROVIDING REDUCED
RETICLE HEATING

Examiner: Lam S. Nguyen

Date: July 16, 2003

COMMISSIONER FOR PATENTS
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CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on July 16, 2003, as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

Donald L. Styling
Attorney for Applicant

AMENDMENT AND REPLY TO OFFICE ACTION

This responds to the Office action dated January 16, 2003. Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Remarks begin on page 4.

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